



UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829  
Examiner: J. Hollington

In Re PATENT APPLICATION Of:

Applicant:	Mikio OHTAKI	)	
Appln. No.:	09/904,663	)	
Filed:	July 16, 2001	)	<u>AMENDMENT</u>
For:	METHOD FOR MANUFACTURING AND BATCH TESTING SEMICONDUCTOR DEVICES	)	
Atty Ref.:	KAN 120D1	)	

March 3, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
**Mail Stop RCE**

Sir:

This Amendment is submitted with the Applicant's Request for Continued Examination (RCE) pursuant to 37 C.F.R. §1.114(a). The RCE is timely filed in response to the Final Office Action dated December 3, 2003. Prior to continued examination, please amend the above-referenced application as shown on the following pages.

FEE ENCLOSED:\$ 770  
Please charge any further  
fee to our Deposit Account  
No. 18-0002.